

Electronic Acknowledgement Receipt

EFS ID:	1040936		
Application Number:	10518945		
Confirmation Number:	4943		
Title of Invention:	Semiconductor device and method for manufacturing semiconductor device		
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Filer Authorized By:	Joseph Richard Keating		
Attorney Docket Number:	36856.1310		
Receipt Date:	08-MAY-2006		
Filing Date:	13-JUL-2005		
Time Stamp:	13:08:36		
Application Type:	U.S. National Stage under 35 USC 371		
International Application Number:			

Payment information:

Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Change of Address	36856-1310-PTO-20060508-change_of_correspondence_of_address.pdf	275307	no	1

Warnings:**Information:**

Total Files Size (in bytes):

275307

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.